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COMMISSIONER FOR PATENTS
Washington, D.C. 20231

Sir:

Transmitted herewith for filing is the patent application of

Inventor(s): Koji KIKUCHI

For: MANUFACTURING METHOD OF A PHASE SHIFT MASK, METHOD OF FORMING A RESIST PATTERN AND MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

Enclosed are:

- Specification and Claim(s).
- Oath or Declaration (Unexecuted).
- 7 sheet(s) of drawings.
- An assignment of the invention to _____.
- Copy of One priority application(s).
- Information Disclosure Statement

The fee has been calculated as shown below:

CLAIMS AS FILED				
FOR	NUMBER FILED	NUMBER EXTRA	RATE	BASIC FEE \$355/\$710
TOTAL CLAIMS	15-20	0	X \$ 9 \$18	\$0
INDEP. CLAIMS	3	0	X \$40 \$80	\$0
Fee for Multiple Dependent Claims \$135/\$270				\$0
			TOTAL FILING FEE	\$710.00

- A Preliminary Amendment is attached.
- °Verified Statement claiming small entity status is enclosed.
- Charge \$ 710.00 to Deposit Account No. 18-0013 to cover the filing fee. A duplicate copy of this sheet is enclosed.
- The Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 or 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 18-0013. A duplicate copy of this sheet is enclosed.
- A check in the amount of \$ cover the filing fee is enclosed.
- Charge \$ to Deposit Account No. 18-0013 to cover the recordal fee. A duplicate copy of this sheet is enclosed.
- Applicant's undersigned attorney may be reached by telephone in our Washington D.C. Office at

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All correspondence should be directed to our below listed address.



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